

CERTIFICATE OF MAILING
I hereby certify that this paper and every
paper referred to therein as being enclosed
is deposited with the U.S. Postal Service
as first class mail, postage prepaid, in
an envelope addressed to Commissioner
for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
on February 13, 2008 (Date of Deposit)

PATENT

Atty. Docket No.: 006915 USA P02/FEP/P3I/AG
RW Ref. No.: APM/001-02-CP1-2



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: :
Kenneth Collins, et al. :
 :
Entitled: PLASMA IMMERSION ION :
IMPLANTATION APPARATUS USING A : Group Art Unit: 2813
PLASMA SOURCE HAVING LOW :
DISSOCIATION AND LOW MINIMUM :
PLASMA VOLTAGE :
 : Examiner: Jack S. Chen
Serial No.: 10/646,533 :
 :
Filing Date: August 22, 2003 :

RESPONSE TO DOUBLE PATENTING REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action (Double Patenting) dated
January 9, 2008, applicants submit herewith a Terminal
Disclaimer to overcome the double patenting rejection.

Although the claims have not been amended, a complete listing of
claims is provided and begins on page 2.

Remarks begin on page 17 of this paper.